

**Notice of References Cited**

Application/Control No.

10/540,019

Applicant(s)/Patent Under

Reexamination

IWATA ET AL.

Examiner

Long Pham

Art Unit

2814

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2006/0208312	09-2006	Iwata et al.	257/324
	B	US-			
	C	US-			
	D	US-			
	E	US-			
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**FOREIGN PATENT DOCUMENTS**

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